

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 7805

SERIAL NUM	BER FILING or				GR	GROUP ART UNIT		ATTORNEY DOCKET				
10/085,04	16	03/01/2			438		2823		03	500.010530.5		
		RUL	E									
APPLICANTS Kiyofumi Sakaguchi, Isehara-shi, JAPAN; Takao Yonehara, Atsugi-shi, JAPAN; Nobuhiko Sato, Yokohama-shi, JAPAN; ** CONTINUING DATA **********************************												
which is a DIV of 08/863,717 05/27/1997 PAT 5,856,229 which is a CON of 08/401,237 03/09/1995 ABN This application 10/085,046 03/01/2002 is a CIP of 09/734,667 12/13/2000 ABN which is a DIV of 09/212,432 12/16/1998 PAT 6,246,068 which is a DIV of 08/729,722 10/07/1996 PAT 5,854,123 This application 10/085,046 03/01/2002 is a CIP of 09/933,711 08/22/2001 ABN which is a DIV of 09/840,895 04/25/2001 PAT 6,350,702 which is a DIV of 08/807,604 02/27/1997 PAT 6,294,478												
** FOREIGN APPLICATIONS ************************************												
04/25/20		∏ √ □ N- □		1	07175 00					INDEDENIE I		
Foreign Priority claimed Yes No 35 USC 119(a-d) conditions met Yes No			☐ Met afte	ter	STATE OR COUNTRY		HEETS WINGS	TOT.		INDEPENDENT CLAIMS		
	/GEORGE FOURSON Examiner's	III/	Initials		JAPAN		24	60		16		
ADDRESS		5				•						
FITZPATRICK CELLA HARPER & SCINTO 1290 Avenue of the Americas NEW YORK, NY 10104-3800 UNITED STATES												
TITLE												
Process for production of semiconductor substrate												
							☐ All Fees					
							☐ 1.16 Fees (Filing)					
									☐ 1.17 Fees (Processing Ext. of time)			